

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Armbrust et al.

Serial No.: 09/666,325

Group Art Unit: 2811

Filed: September 21, 2000

Examiner: Kang, D.

For: SELF-ALIGNED COPPER SILICIDE FORMATION FOR IMPROVED
ADHESION/ELECTROMIGRATIONAssistant Commissioner of Patents
Washington, D.C. 20231#18/D
9/10/02
HJM/TKAMENDMENT UNDER 37 C.F.R. §1.111

Sir:

In response to the Office Action mailed June 5, 2002, please amend the application as follows.

IN THE CLAIMS:

Please substitute the following claims for the same numbered claims in the application.

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CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)

Applicant(s): Armbrust et al.

Docket No.

BU9-98-110 DIV

Serial No.
09/666,325Filing Date
September 21, 2000Examiner
D. KangGroup Art Unit
2811Invention: **SELF-ALIGNED COPPER SILICIDE FORMATION FOR IMPROVED ADHESION/
ELECTROMIGRATION****FAX COPY RECEIVED**

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I hereby certify that this AMENDMENT UNDER 37 CFR 1.111
(Identify type of correspondence)
is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. 703-872-9318)
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Frederick W. Gibb, III

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